

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re the Application of:

Koji SHIGEMURA et al.

Application No. 10/718,640

Group Art Unit: 2879

Confirmation No. 1164

Filed: November 24, 2003

Examiner: Natalie K. Walford

For: EVAPORATION MASK, METHOD OF FABRICATING ORGANIC  
ELECTROLUMINESCENT DEVICE USING THE SAME, AND ORGANIC  
ELECTROLUMINESCENT DEVICE

**COMMUNICATION REGARDING INFORMATION DISCLOSURE STATEMENT  
PREVIOUSLY FILED**

Commissioner for Patents  
PO Box 1450  
Alexandria, VA 22313-1450

Sir:

Further to the Notice of Allowance mailed by the Examiner on August 25, 2010, the Applicants respectfully request that the Information Disclosure Statement filed February 21, 2008, be considered by the Examiner.

A copy of the Information Disclosure Statement is included in the image file wrapper, and is not again included. Since the Information Disclosure Statement was timely filed in accordance with the provisions of 37 CFR §1.97, it is respectfully submitted that the Examiner confirm consideration by initialing the attachment 1(a) included with the Information Disclosure Statement.

Applicants note that although the Examiner provided a copy of attachment 1(a), noted in the Information Disclosure Statement filed February 21, 2008, with the Office Action dated October 29, 2008, the Examiner appears to have inadvertently forgotten to initial the references noted in the Information Disclosure Statement filed February 21, 2008.

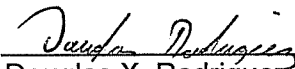
Accordingly, Applicants respectfully request that the Examiner initial and consider the

references cited in the Information Disclosure Statement filed February 21, 2008.

Respectfully submitted,

STEIN, MCEWEN & BUI, LLP

Date: AUG-26-2010

By:   
Douglas X. Rodriguez  
Registration No. 47,269

1400 Eye Street N.W.  
Suite 300  
Washington, D.C. 20005  
Telephone: (202) 434-1500  
Facsimile: (202) 434-1501